

10/768,568

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-2496		Priority SERIAL NO. 09/043,137	
		LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)			APPLICANT Jerome Eldridge			
					Priority FILING DATE August 30, 2001		Priority GROUP 2822	
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
KBD	AA	5,350,738	9/94	Haze et al				
	AB	5,272,341	12/93	Micheli et al				
	AC	5,142,437	08/92	Kammerdiner et al				
	AD	6,461,931	10/02	Eldridge				
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↓	AI	5,953,619	09/99	Miyazawa				
	AJ							
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		Document Number	Date	Country	Class	Subclass	Translation	
KBD	AK	EP 0727832 A1	08/96	EPO/Miyashita et al			Yes	No
	AL							
	AM							
	AN							
	AP							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
KBD	AP		John Baliga, "New Materials Enhance Memory Performance", Semiconductor International, November 1999, pgs. 1-8.					
	AQ		Advances in Ultrathin Oxides and Oxynitrides I", Materials Research Society Symposium Proceedings Series, Vol. 567., April 5, 1999, 2 pages.					
↓	AR		K.S. Tang, W.S. Lau, and G.S. Samudra, "Trends in Dram Dielectrics", IEEE Circuits & Devices, Vol. 13, No. 3, May 1997, pgs. 27-34					
EXAMINER	<i>John B. Tracy</i>			DATE CONSIDERED		8/22/2004		
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2496	Priority SERIAL NO. 09/945,137		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Jerome Eldridge			
				PRIORITY FILING DATE August 30, 2001	PRIORITY GROUP 2822		
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
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FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AK						
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
<i>KBD</i>	AP		D.W. Hess, "Plasma-assisted oxidation, anodization, and nitridation of silicon", IBM Journal of Research & Development, Vol. 43, No. 1/2, Plasma processing, 22 pages.				
	AQ		O. Kubaschewski, E. LL. Evans, "Metallurgical Thermochemistry", Pergamon Press, 1958, pgs. 226-227 and 336-337				
<i>↓</i>	AR		Ting, Chen, Liu, "Structural evolution and Optical properties of TiO <sub>2</sub> thin films prepared by thermal oxidation of sputtered Ti films", Journal of Applied Physics, Vol. 88, Number 9, 15 October 2000, pgs.4628-4633.				
EXAMINER	<i>John B. Dray</i>			DATE CONSIDERED	<i>8/22/2001</i>		
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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2496		Priority SERIAL NO. 09/943,137	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Jerome Eldridge			
				Priority FILING DATE August 30, 2001		Priority GROUP 2822	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA						
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FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes      No
	AK						
	AL						
	AM						
	AN						
	AO						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
<i>KBD</i>	AP	O. Kubaschewski, B.E. Hopkins, "Oxidation of Metals and Alloys", Butterworths ,London, Second Edition, 1962, pgs. 36-37 and 70-73.					
	AQ	F.P. Fehlner, "Low-Temperature Oxidation", Monograph published by Electrochemical Society, Pennington, New Jersey, 1983, pgs.31-35.					
<i>↓</i>	AR	Richard A. Swalin, "Thermodynamics of Solids" Second Edition, Chpt 5, John Wiley & Sons, 1972, pgs. 112-115.					
EXAMINER	<i>John R. Roy</i>			DATE CONSIDERED	<i>8/22/2001</i>		
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